

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Confirmation No. 2271

Tetsuji TOGAWA et al. : Docket No. 2001-1103

Serial No. 09/922,776 : Group Art Unit 3723

Filed August 7, 2001 : Examiner Robert A. Rose

POLISHING APPARATUS

In re application of

## **AMENDMENT**

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the Office Action of September 10, 2003, the period for response to which having been extended by two months to February 10, 2004, kindly amend the above-referenced U.S. patent application as follows:

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**TECHNOLOGY CENTER R3700**